



AF
IPW

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Final, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: June 28, 2005

Signature:

(Michael R. Hull)

Docket No.: 29926/39504
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ju-Il Lee

Application No.: 10/669,996

Confirmation No.: 6198

Filed: September 24, 2003

Art Unit: 2813

For: METHOD FOR MANUFACTURING CMOS
IMAGE SENSOR USING SPACER ETCHING
BARRIER FILM

Examiner: Monica D. Harrison

AMENDMENT AFTER FINAL (37 C.F.R. §1.116)

MS Final
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the final office action dated April 28, 2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.